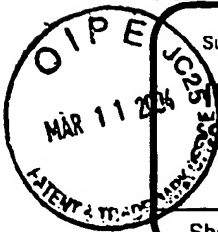


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 2

Complete if Known

Application Number	10/029,101
Filing Date	December 20, 2001
First Named Inventor	Woodin
Art Unit	2815
Examiner Name	Jose Diaz
Attorney Docket Number	90065.001010/17732.8010

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
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FOREIGN PATENT DOCUMENTS

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 2

Complete if Known

Application Number	10/029,101
Filing Date	December 20, 2001
First Named Inventor	Woodin
Art Unit	2815
Examiner Name	Jose Diaz
Attorney Docket Number	90065.001010/17732.8010

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
2	1	"Interface Chemistry and Electrical Properties of Annealed Ni and Ni/Al-6H SiC Structures", C. Halling, R. Yakimova, V. Krastev, Ts. Marinova and E. Janzen, Inst. Phys. Conf. Seri No. 196, 1996 IOP Publishing Ltd.	
2	2	"The Influence of Dry Cleaning Techniques on Thermal Oxides Grown on 4H and 6H P-type SiC", C.-M. Zetterling, C.I. Harris, M. Ostling and V.V. Afanas'ev", Inst. Phys. Conf. Seri No. 196, 1996 IOP Publishing Ltd.	
2	3	"Specific Contact Resistance as a Function of Doping N-type 4H and 6H-SiC", Inst. Phys. Conf. Seri No. 196, 1996 IOP Publishing Ltd.	
2	4	"Aluminum Doped 6H SiC: CVD Growth and Formation of Ohmic Contacts", Inst. Phys. Conf. Seri No. 196, 1996 IOP Publishing Ltd.	

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